



Electronic Filing System (EFS) Data
Electronic Patent Application Submission
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EFS ID: 49917
Application ID: 09912844
Title of Invention: HIGH PRESSURE PROCESSING
CHAMBER FOR SEMICONDUCTOR
SUBSTRATE
First Named Inventor: Thomas Haverstock
Domestic/Foreign Application: Domestic Application
Filing Date: 2001-07-24
Effective Receipt Date: 2003-10-29
Submission Type: Information Disclosure
Statement
Filing Type:
Confirmation number: 5915
Attorney Docket Number: NONE




Total Fees Authorized:

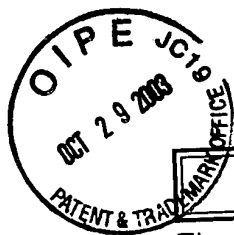
Digital Certificate Holder: cn=Thomas B. Haverstock,ou=Registered Attorneys,ou=Patent and
Trademark Office,ou=Department of Commerce,o=U.S. Government,c=US
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TRANSMITTAL

Electronic Version v1.1
Stylesheet Version v1.1.0

Title of Invention	HIGH PRESSURE PROCESSING CHAMBER FOR SEMICONDUCTOR SUBSTRATE									
<p>Application Number: 09/912844 </p> <p>Date: 2001-07-24</p> <p>First Named Applicant: Thomas B. Haverstock</p> <p>Confirmation Number: 5915</p> <p>Attorney Docket Number:</p>										
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<table border="1"><thead><tr><th>Submitted by:</th><th>Elec. Sign.</th><th>Sign. Capacity</th></tr></thead><tbody><tr><td>Maximilian A. Biberger Registered Number: 32571</td><td>/tbh/</td><td>Attorney</td></tr></tbody></table>			Submitted by:	Elec. Sign.	Sign. Capacity	Maximilian A. Biberger Registered Number: 32571	/tbh/	Attorney		
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Maximilian A. Biberger Registered Number: 32571	/tbh/	Attorney								
<table><tr><td>Documents being submitted</td><td>Files</td></tr><tr><td>us-ids</td><td>SSI00501D-usidst.xml</td></tr><tr><td></td><td>us-ids.dtd</td></tr><tr><td></td><td>us-ids.xsl</td></tr></table>			Documents being submitted	Files	us-ids	SSI00501D-usidst.xml		us-ids.dtd		us-ids.xsl
Documents being submitted	Files									
us-ids	SSI00501D-usidst.xml									
	us-ids.dtd									
	us-ids.xsl									
Comments										



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

Title of Invention	HIGH PRESSURE PROCESSING CHAMBER FOR SEMICONDUCTOR SUBSTRATE
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Application Number: 09/912844
Confirmation Number: 5915
First Named Applicant: Thomas Haverstock
Attorney Docket Number:
Search string: (6521466 or 6541278 or 6546946 or 6550484
or 6558475 or 6561213 or 6561220 or 6561481
or 6561767 or 6564826 or 5217043 or
20020001929).pn.



US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6521466	2002-02-18	Castrucci	B1		
	2	6541278	2003-04-01	Morita et al.	B1		
	3	6546946	2003-04-15	Dunmire	B1		
	4	6550484	2003-04-22	Gopinath et al.	B1		
	5	6558475	2003-05-06	Jur et al.	B1		
	6	6561213	2003-05-13	Wang et al.	B1		
	7	6561220	2003-05-13	McCullough et al.	B1		
	8	6561481	2003-05-13	Filonczuk	B1		
	9	6561767	2003-05-13	Biberger et al.	B1		
	10	6564826	2003-05-20	Shen	B1		
	11	5217043	1993-06-08	Novakovi			

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20020001929	2002-01-03	Biberger et al.	A1		

Remarks

Note: Remarks are not for responding to an office action.

Non US Patent and Publication references shall be filed under a separate paper transmittal. The current electronic filing contains part 4 out of a total of 4 electronic filings. Fee has been paid in previous electronic filing.

Signature

Examiner Name	Date